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| PTO/SB/08A | | | | Complete if Known | |
| SEVENTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary) OCT 28 2003 | | | | Application Number | 09/607,535 |
| | | | | Filing Date | June 29, 2000 |
| | | | | Confirmation Number | 8642 |
| | | | | First Named Inventor | Shenheng Guan, et al. |
| | | | | Group Art Unit | 1743 |
| | | | | Examiner Name | Dwayne K. Handy |
| Sheet 1 of 1 | Attorney Docket No. | SMX 3161.1 (98-13DIV1) | | | |

| U.S. PATENT DOCUMENTS | | | | | | |
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| Examiner Initials* | Cite No. ¹ | U.S. Patent Document | | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document MM-DD-YYYY | |
| | | Number | Kind Code ² (if known) | | | |
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| Examiner Initials* | Cite No. ¹ | Foreign Patent Document | | | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document MM-DD-YYYY | T ⁶ |
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| DKM | 61. | "Nanoflowreactor nu in zesvoud uitgevoerd!", LabSpiegel, September 23, 1988, Royal/Shell Laboratory, Amsterdam | ✓ |
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|--------------------|------------------------|-----------------|----------|
| Examiner Signature | <i>Dwayne K. Handy</i> | Date Considered | 12/18/03 |
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